



PATENT
Docket No. 506212001100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Michihiko YANAGISAWA *et al.*

Serial No.: 10/623,740

Filing Date: July 22, 2003

For: LOCAL DRY ETCHING METHOD

Examiner: Shamim Ahmed

Group Art Unit: 1765

Conf. No.: 5259

Do Not
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S&P
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AMENDMENT UNDER 37 CFR 1.116

M/S AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Action mailed October 20, 2005, please amend this application as follows:

The listing of claims begins on page 2.

The Remarks begin on page 4.